PATENT

ÍN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Magaut a Sulliva

Applicant

I. Kizilyalli, et al.

Application No.

09/516.004

Filed

February 29, 2000

Title

SELECTIVE LASER ANNEAL ON SEMICONDUCTOR

MATERIAL

Grp./Div.

2811

Examiner

O. Nadav

Docket No.

45368/SAH/A717

RESPONSE TO OFFICE ACTION DATED MAY 1, 2001

Assistant Commissioner for Patents Washington, D.C. 20231

Post Office Box 7068 Pasadena, CA 91109-7068 October 1, 2001

Commissioner:

In response to the Office action of May 1, 2001, please amend the above-identified application as follows, and re-examine and reconsider the application in view of the remarks provided.

A petition for a two-month extension of time and the appropriate fee are enclosed herewith.

AMENDMENTS

In the Claims:

Please amend claims 6 and 9 as indicated in the attached Version with Markings to Show Changes Made. Claims 1-5 and 12-23 had previously been withdrawn from present consideration. The set of pending claims 6-11 is as follows:

6. (Amended) An integrated circuit comprising: